

FINGERPRINT RECOGNITION SENSOR AND MANUFACTURING METHOD  
THEREOF

BACKGROUND OF THE INVENTION

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Field of the Invention

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The present invention relates to a fingerprint recognition sensor and its manufacturing method, and more particularly to a one chip-based finger recognition  
10 sensor using a CMOS (Complementary Metal-oxide Semiconductor) sensor and its manufacturing method.

Description of the Background Art

Generally, in order for portable information  
15 communication instruments such as a mobile phone or a portable computer (that is, a laptop computer) to have a security function by using fingerprints, a very thin fingerprint recognition sensor is required.

Figure 1 is a schematic view of a fingerprint  
20 recognition system in accordance with a conventional art.

As shown in the drawing, a conventional fingerprint recognition system includes an image generator 10 and a sensor-arranged part 20.

The image generator 10 includes a single electrode

electro-luminescence device 12 and an A/C power source 14, and the single electrode electro-luminescence device 12 includes a transparent electrode 13, a luminescent layer and a dielectric layer 17.

5           However, the conventional fingerprint recognition system constructed as described above has a problem that, since the image generator 10 and the sensor-arranged part 20 are separated at a distance to each other, the light coming out of the image generator 10 spreads out  
10 to reach the surface of the sensor-arranged part 20 like the arrows as shown in Figure 1, rather than traveling straight, resulting in that an optical image of fingerprints is unclear.

          In this respect, the longer the image generator 10  
15 is away from the sensor-arranged part 20, the more the light radiating from the image generator 10 is lost, so that the optical image of the fingerprints grows more dim.

          In detail, in the conventional fingerprint  
20 recognition system, the light coming out of the luminescent layer 15 is radiated in three-dimensional manner. At this time, since the light is reflected on the dielectric layer 17, the light is thus directed to the sensor-arranged part 20. In this respect, the light

spreads in a two-dimensional manner, rather than going straight ahead, to reach the surface of the sensor-arranged part 20. And, at this time, the light works on the light reflected on the dielectric layer 17, creating  
5 a noise, so that a high contrast image is hardly obtained.

Also, in this case, since the light generated due to the ridge of a fingerprint spreads toward the valley of the fingerprints, it is very difficult to obtain a  
10 high-quality fingerprint from a sweat hand of a person.

In addition, the surface of the single electrode electro-luminescence unit 12 is made of a dielectric layer 17. Thus, in case that it is employed as a fingerprint recognition element to be used by numerous  
15 persons (i.e., in case of a fingerprint image which has been taken by more than 100 times, which is repeated for a week), as shown in Figure 2, the surface of the fingerprint recognition element is contaminated by dirt of fingerprints, degrading the finger image.

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#### SUMMARY OF THE INVENTION

Therefore, an object of the present invention is to provide a single-chip fingerprint recognition sensor

using a CMOS sensor which is capable of overcoming the problems of the conventional art, and its manufacturing method.

Another object of the present invention is to  
5 provide a fingerprint recognition system using a CMOS sensor having a ground frame structure which facilitates acquiring fingerprints as well as providing a desirable fingerprint image.

To achieve these and other advantages and in  
10 accordance with the purpose of the present invention, as embodied and broadly described herein, there is provided a fingerprint recognition sensor including: a CMOS image sensor; a transparent electrode layer disposed at an upper portion of the CMOS image sensor; a luminescent  
15 layer disposed at the upper portion of the transparent electrode layer and having fluorescent particles and a binder; a dielectric layer disposed at the upper portion of the luminescent layer; and contamination-resistance film disposed at the upper portion of dielectric layer.

20 In order to achieve the above objects, there is also provided a method for manufacturing a fingerprint recognition sensor, including the steps of: providing a CMOS image sensor; depositing a transparent electrode layer as a thin film on the upper portion of the CMOS

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image sensor, to which a terminal of an AC power source is connected, the transparent electrode layer being made of a transparent insulating material and a transparent conductive material; forming a luminescent layer at the upper portion of the transparent electrode layer to generate a light image; forming a dielectric layer at the upper portion of the luminescent layer; and forming a contamination-resistance film at the upper portion of the dielectric layer.

The foregoing and other objects, features, aspects and advantages of the present invention will become more apparent from the following detailed description of the present invention when taken in conjunction with the accompanying drawings.

#### BRIEF DESCRIPTION OF THE DRAWINGS

The accompanying drawings, which are included to provide a further understanding of the invention and are incorporated in and constitute a part of this specification, illustrate embodiments of the invention and together with the description serve to explain the principles of the invention.

In the drawings:

Figure 1 is a schematic view showing a fingerprint recognition system in accordance with a conventional art;

Figure 2 is a view showing a fingerprint image  
5 obtained by adopting the fingerprint recognition system of Figure 1 in accordance with the conventional art;

Figure 3 is a sectional view of a fingerprint recognition sensor in accordance with one embodiment of the present invention;

10 Figure 4 is a sectional view of a luminescent layer, a major part in accordance with the present invention;

Figure 5 is a view showing a fingerprint image obtained by adopting the fingerprint recognition system  
15 in accordance with one embodiment of the present invention; and

Figures 6A through 6C illustrate a fingerprint recognition system in accordance with another embodiment of the present invention, of which

20 Figure 6A is a sectional view of a fingerprint recognition system using a CMOS sensor;

Figure 6B is a plan view of the fingerprint recognition system using the CMOS sensor of Figure

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6A; and

Figure 6C is a schematic perspective view of a ground frame, a major part.

5 DETAILED DESCRIPTION OF THE PREFERRED EMBODIMENTS

Reference will now be made in detail to the preferred embodiments of the present invention, examples of which are illustrated in the accompanying drawings.

10 Figure 3 is a sectional view of a fingerprint recognition sensor in accordance with one embodiment of the present invention, and Figure 4 is a sectional view of a luminescent layer, a major part in accordance with the present invention.

15 As shown in Figures 3 and 4, the fingerprint recognition sensor includes, at large, a CMOS image sensor 30 and a contact luminous element 40. The contact luminous element 40 includes a transparent electrode layer 32 formed at the upper portion of the CMOS image  
20 sensor 30, a luminescent layer 34 formed at the upper portion of the transparent electrode layer 32 and having fluorescent particles 42 and a binder 44, a dielectric layer 36 formed at the upper portion of the luminescent layer 34, and a contamination-resistance layer 38 formed

at the upper portion of the dielectric layer 36.

Though not shown, one terminal of AC power source is connected to one end of the transparent electrode layer 32.

5       The fingerprint recognition sensor of the present invention is featured in that the transparent electrode layer 32 of the contact luminous element 40 is directly deposited as a thin film on the surface of the CMOS image sensor 30.

10       In the case that the CMOS image sensor 30 is utilized in this manner, since an analog signal is converted to a digital data to be outputted, any additional circuit related to a digital conversion of an image signal is not required, so that its circuit  
15 construction can be simplified.

Meanwhile, a method for manufacturing a fingerprint recognition sensor, includes the steps of: providing a CMOS image sensor 30; depositing a transparent electrode layer 32 as a thin film on the  
20 upper portion of the CMOS image sensor, to which a terminal of an AC power source is connected, the transparent electrode layer being made of a transparent insulating material and a transparent conductive material; forming a luminescent layer 34 at the upper





luminescent, a noise image due to sweat can be minimized.

The contamination-resistance film 38 of the present invention is formed by using  $\text{TiO}_2$  powder, that is, a photocatalytic material, and a polymer binder. As the  
5  $\text{TiO}_2$  powder has a quite low affinity with moisture, a main constituent of sweat, or oiliness, its contamination-resistance is very strong to sweat or dirt. Thus, as shown in Figure 5, the fingerprint image is not degraded.

In other words, when ultraviolet rays are radiated  
10 on the contamination-resistance film,  $\text{TiO}_2$  works as a photo-catalyst, having a characteristic of dissolving dirt itself.

Figures 6A through 6C illustrate a fingerprint recognition system in accordance with another embodiment  
15 of the present invention, of which Figure 6A is a sectional view of a fingerprint recognition system using a CMOS sensor; Figure 6B is a plan view of the fingerprint recognition system using the CMOS sensor of Figure 6A; and Figure 6C is a schematic perspective view  
20 of a ground frame, a major part.

As shown in the drawing, the fingerprint recognition system in accordance with another embodiment of the present invention includes a CMOS image sensor 50, a transparent electrode thin film 60 directly deposited

as a thin film on the surface of the CMOS image sensor 50, and a fingerprint recognition sensor 70 installed at the upper portion of the transparent electrode thin film 60.

5        On the fingerprint recognition sensor 70, as shown in Figure 6C, a ground frame 72 is formed, to which one terminal of an AC power source (not shown) is applied and the other terminal of the AC power source is applied to the transparent electrode thin film 60. And, at least  
10 one pin 48 is disposed at a predetermined portion of the ground frame 72.

      The operation of the fingerprint recognition sensor constructed as described above in accordance with another embodiment of the present invention will now be  
15 explained.

      After an AC power source is applied to the transparent electrode thin film 60 and to the ground frame 72, when fingerprints simultaneously contact the surface of the fingerprint recognition sensor 70 and the  
20 ground frame 72, an optical image of the fingerprint is generated by the fingerprint recognition sensor 70. The optical image is converted to a digital signal by the CMOS image sensor 50 and transmitted to a matching system (not shown).

As so far described, the fingerprint recognition sensor and manufacturing method thereof has the following advantages.

That is, first, since the CMOS image sensor is  
5 utilized, any additional circuit is not required for digital conversion of the image signal, so that the circuit construction can be simplified.

Secondly, since the transparent electrode is directly deposited as a thin film on the surface of the  
10 CMOS image sensor, on which the fingerprint recognition sensor is installed, a fingerprint image having a good contrast can be obtained.

As the present invention may be embodied in several forms without departing from the spirit or  
15 essential characteristics thereof, it should also be understood that the above-described embodiments are not limited by any of the details of the foregoing description, unless otherwise specified, but rather should be construed broadly within its spirit and scope  
20 as defined in the appended claims, and therefore all changes and modifications that fall within the meets and bounds of the claims, or equivalence of such meets and bounds are therefore intended to be embraced by the appended claims.